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PATENT
740756-2197

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Kenji KASAHARA et al.

Serial No. 09/640,521

Filed: August 17, 2000

For: LASER APPARATUS AND LASER
ANNEALING METHOD

) Group Art Unit: 1725

) Examiner: Geoffrey S. Evans

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being
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) Washington, D.C. 20231, on March 28, 2002

) Gwyn J. Cantrell
Gwyn J. Cantrell

AMENDMENT

Honorable Commissioner of Patents
Washington, D.C. 20231

Dear Sir:

In response to the Examiner's non-final Office Action mailed November 28, 2001, the period for responding having been extended One (1) month, please consider the following amendments and remarks in connection with the above-identified application.

IN THE CLAIMS:

Please amend claims 4, 6, 9, 21, 24 and 27 as follows. Claims 4, 6, 9, 21, 24 and 27 are presented below in their amended form. The amendments to the above-noted claims are outlined in an Attachment to the Amendment using the conventional indication method of bracketing and underlining.

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4. (Amended) A laser apparatus, comprising:
a laser source for emitting a laser light;
a half mirror for dividing the laser light into a first laser light and a second laser light;
an optical system for guiding the first laser light and the second laser light onto a top surface
and a back surface of an object to be treated, respectively,
wherein the optical system includes a filter for attenuating the first laser light.

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04 FC:103

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